## **AMENDMENTS TO THE SPECIFICATION:**

Please replace paragraph [0003] with the following amended paragraph:

United States Patent Application 10/664,169 entitled "A Product and Process for Bonding Porous Materials to Substrates" filed concurrently herewith, with inventors Buhler and Littau.

Please replace paragraph [0004] with the following amended paragraph:

United States Patent Application 10/665,052 entitled "A Product and Process for Bonding Porous Materials to Substrates" filed concurrently herewith, with inventors Buhler and Littau.

Please replace paragraph [0005] with the following amended paragraph:

United States Patent Application 10/664,472 entitled "Piezoelectric Transducers" filed concurrently herewith, with inventors Buhler, Littau, Fitch, Andrews, Burke, Nystrom, and Schmachtenberg.